IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: |) Previous Examiner: K. Sagar |
|--|-------------------------------------|
| Takako YAMAGUCHI et al. | :) Previous Group Art Unit: 1756 . |
| Application No.: Divisional of Application No. 09/781,331, filed February 13, 2001 | :) : |
| Filed: July 31, 2003 |) :) July 31, 2003 |
| For: PATTERN-FORMING APPARATUS USING A PHOTOMASK (As Amended) | , <u>,</u> , |

Mail Stop Patent Application

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT AND LETTER SUBMITTING SUBSTITUTE SPECIFICATION

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

IN THE TITLE

Please amend the title as shown in the substitute specification.